



Handwritten initials: JPD

PATENT APPLICATION

IN THE U.S. PATENT AND TRADEMARK OFFICE

July 17, 2008

Applicant(s): Takaomi NAKAYAMA et al

For: TREATING SOLUTION FOR SURFACE TREATMENT OF METAL AND A
METHOD FOR SURFACE TREATMENT

Serial No.: 10/537 329 Group: 1793
Confirmation No.: 8404
Filed: December 2, 2005 Examiner: Zheng
International Application No.: PCT/JP2003/015868
International Filing Date: December 11, 2003
Atty. Docket No.: 4626.P0002US

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUPPLEMENTAL RESPONSE

Sir:

Further to the Response filed July 7, 2008, please amend
the above-identified application as follows:

(Please see following pages.)

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being
deposited with the United States Postal Service with
sufficient postage as first class mail in an envelope
addressed to: Commissioner for Patents, P.O. Box 1450,
Alexandria, VA 22313-1450, on July 17, 2008.

Handwritten signature of Terryence F. Chapman

Terryence F. Chapman